



U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10080468	FILING DATE 02/22/2002	CLASS 438	SUBCLASS 4247	GAU 2812	EXAMINER A D MA
**APPLICANTS: Ji Hua;					
**CONTINUING DATA VERIFIED:					
BEST AVAILABLE COPY					
** FOREIGN APPLICATIONS VERIFIED:					
PG-SUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no			ATTORNEY DOCKET NO		
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no			M-12589 US		
Verified and Acknowledged Examiner's initials					
TITLE : HDP CVD process for void-free gap fill of a high aspect ratio trench					
U.S. DEPT. OF COM. (PAT & TM) PTO-413e/Rev. 12-98					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims <input type="checkbox"/> Print Claims for O/G <input type="checkbox"/>
ISSUE FEE		Primary Examiner	DRAWING
Amount Due	Date Paid		Sheets Draw. <input type="checkbox"/> Figs. Draw. <input type="checkbox"/> Print Figs. <input type="checkbox"/>
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner
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